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Pressure-driven actuators based on dry-films lamination

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From prototyping to mass production

Pressure-driven microfluidic valves have been extensively used since their apparition in 2000, mainly using PDMS as their constitutive material.
While PDMS valves processing is well suited to rapid prototyping, it is not optimal for large-scale manufacturing.

• We offer an alternative approach based on the **double exposure** of **laminated** DF-1000 Series **dry-films**. **Step-by-step workflow:** DF-1050 negative photoresists dry films from EMS are laminated with a Shipley 3024 laminator. Membrane thickness is adjusted by exposure dose at step 3. The workflow can be **extended to other photosensitive dry-films** by tailoring processing parameters.



Every layer is processed by conventionnal photolithography.
It allows excellent alignment precision and a mass-production compatible workflow at the wafer scale level.

Proof of concept: peristaltic micropump

In order to demonstrate the potentialities of this method, several common microfluidic components taken from the literature have been realized, including normally-closed valves, diodes, single-stroke peristaltic pumps, suspended herring-bone mixers ...

While the relatively high Young modulus of dry-films vs. PDMS impose higher pressure to obtain enough deflection of the membranes, its gas-tight nature allows thinner membranes to be used.







Bake and develop cover layer.

This combination of properties leads to faster response time of the dry-film membranes, which translates to a larger actuation bandwidth in the case of peristaltic pumps.

 A single-stroke peristaltic pump, based on the design from *H. Lai*, *A. Folch 2011, Lab on a Chip 11 336–42*, and without optimization of its geometry for dry-films offers a cut-off frequency approx.
4 times higher than its PDMS counterpart. Key features of laminated dry-films for microfluidics

Material properties: biocompatible, resistant to most organic solvents (tested against ethanol, isopropanol, acetone, DMSO).

Processing: cheaper and faster to process than

30



making SU-8 molds and casting PDMS.

500µm

No more manual steps: the workflow is compatible with wafer-scale collective manufacturing enabling integration of fluidic functions on microsensors.

Opens up new possibilities: using the ability to produce suspended features of controlled thickness, passive flow-sensors, mixers, or microcantilevers can be easily integrated.

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